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	Application No.	Applicant(s)	
Notice of Allowability	10/749,505	TANAKA ET AL.	
	Examiner	Art Unit	
	M. Wilczewski	2822	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT F of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED i) or other appropriate comm RIGHTS. This application is	in this application. If not included nunication will be mailed in due co	l ourse. THIS
1. $igtimes$ This communication is responsive to <u>the Amendment filed</u>	d on May 16, 2007.		
2. 🔀 The allowed claim(s) is/are <u>10-28,36,37,39-48 and 50-75</u>			
 Acknowledgment is made of a claim for foreign priority to a) All b) Some* c) None of the: None of the: Certified copies of the priority documents have: Certified copies of the priority documents have: Copies of the certified copies of the priority documents have: Copies of the certified copies of the priority documents have: Copies of the certified copies of the priority documents have: Certified copies of the certified copies of the priority documents have: Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 	re been received. re been received in Applicati ocuments have been receive " of this communication to fil	on No ed in this national stage application	
4. A SUBSTITUTE OATH OR DECLARATION must be subr INFORMAL PATENT APPLICATION (PTO-152) which give	mitted. Note the attached EXves reason(s) why the oath o	(AMINER'S AMENDMENT or NO or declaration is deficient.	TICE OF
 CORRECTED DRAWINGS (as "replacement sheets") mu (a) including changes required by the Notice of Draftsper 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR) 	rson's Patent Drawing Revie r's Amendment / Comment o 1.84(c)) should be written on	or in the Office action of	ack) of
each sheet. Replacement sheet(s) should be labeled as such in 6. DEPOSIT OF and/or INFORMATION about the dep- attached Examiner's comment regarding REQUIREMENT	osit of BIOLOGICAL MAT	ERIAL must be submitted. No	te the
Attachment(s) 1. □ Notice of References Cited (PTO-892) 2. □ Notice of Draftperson's Patent Drawing Review (PTO-948)		nformal Patent Application Summary (PTO-413),	
	Paper No	./Mail Date	
 Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date May 16, 2007 Examiner's Comment Regarding Requirement for Deposit of Biological Material 		s Amendment/Comment s Statement of Reasons for Allow M. Wilczewski Primary Examiner	ance
		Tech Center 2800	

EXAMINER'S AMENDMENT

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

This application is in condition for allowance except for the presence of claims 1-9 and 29-35 directed to a species of the claimed invention non-elected without traverse. Accordingly, claims 1-9 and 29-35 have been cancelled.

The abstract of the disclosure is objected to because it is not limited to a single paragraph. Accordingly, the abstract has been rewritten as follows:

ABSTRACT OF THE DISCLOSURE

In a laser irradiation system, since a heavy scanning stage moves at a high speed, vibration is caused. When the vibration is transmitted to a vibration isolator where an optical system that forms a beam spot and a system are mounted, a laser irradiation track formed on a substrate, which is not linear any more, is undulating in a reflection of the vibration. It is one of the objects of the present invention to suppress the undulation of the irradiation tracks due to such vibration. A light-shielding film 134 is provided over a semiconductor film 133 that is to be irradiated. When the light-shielding film 134 is provided, a portion of the incident beam, which has a low energy density, is shielded. As described above, providing the light-shielding film 134 makes it possible to enlarge a grain size in the semiconductor film without forming the state similar to the crystals formed in the case of performing laser crystallization with an excimer laser. It is preferable that the light-shielding film 134 be as thin as possible in order to minimize an effect of diffraction.

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Figure 3 was selected as the drawing to be printed on the front page of the patent, so the reference numbers used in the abstract have been changed to those used in Figure 3.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to M. Wilczewski whose telephone number is (571) 272-1849. The examiner can normally be reached on Monday-Thursday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Zandra Smith can be reached on 571-272-2429. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

M. Wilczewski Primary Examiner Tech Center 2800

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